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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/781,689	02/20/2004	Go Miya	500.42015VX1	500.42015VX1 3698	
20457	7590 03/08/2005		EXAMINER		
ANTONELLI, TERRY, STOUT & KRAUS, LLP			ARANCIBIA, MAUREEN GRAMAGLIA		
1300 NORTH SEVENTEENTH STREET SUITE 1800		ART UNIT	PAPER NUMBER		
ARLINGTON, VA 22209-9889			1763		
			DATE MAILED: 03/08/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

Supplemental Notice of Allowability

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Application No.	Applicant(s)	
10/781,689	MIYA ET AL.	
Examiner	Art Unit	
Maureen G. Arancibia	1763	

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The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (0 herewith (or previously mailed), a Notice of Allowance (PTOL-85) of NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGORY of the Office or upon petition by the applicant. See 37 CFR 1.313 at 1. This communication is responsive to 2/14/05.	OR REMAINS) CLOSED in this apport of the appropriate communication GHTS. This application is subject to	olication. If not include will be mailed in due	ed course. THIS
2. The allowed claim(s) is/are <u>14,15 and 17-19</u> .			
3. The drawings filed on 20 February 2004 are accepted by the	e Examiner.		
 4. Acknowledgment is made of a claim for foreign priority under a) All b) Some* c) None of the: 1. Certified copies of the priority documents have to complete a copies of the priority documents have to copies of the certified copies of the priority documents have to copies of the certified copies of the priority documents have to copies of the certified copies of the priority documents have to copies of the certified copies of the priority documents have to copies of the certified copies of the priority documents have to copies of the priority docu	peen received. peen received in Application No. 10 peen received in this communication to file a reply of	national stage applicat	
THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.			07107.05
 A SUBSTITUTE OATH OR DECLARATION must be submitt INFORMAL PATENT APPLICATION (PTO-152) which gives 			OTICE OF
 6. CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftsperso 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the 7. DEPOSIT OF and/or INFORMATION about the depositation attached Examiner's comment regarding REQUIREMENT Formula (see 1.2). 	n's Patent Drawing Review (PTO-S Amendment / Comment or in the O (4(c)) should be written on the drawing the header according to 37 CFR 1.121(c) it of BIOLOGICAL MATERIAL m	office action of the	
 Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☒ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date NOT CONSIDERED 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	5. ☐ Notice of Informal Position 6. ☐ Interview Summary Paper No./Mail Dat 7. ☐ Examiner's Amendn 8. ☒ Examiner's Stateme 9. ☒ Other <u>STATEMENT</u>	(PTO-413), e nent/Comment ent of Reasons for Allo	

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SUPPLEMENTAL

Application/Control Number: 10/781,689

Art Unit: 1763

DETAILED ACTION

Information Disclosure Statement

1. The information disclosure statement filed 02/14/05 **fails to comply** with 37 CFR 1.97(c) because it lacks a statement as specified in 37 CFR 1.97(e). It has been placed in the application file, but the information referred to therein **has not been considered**.

Allowable Subject Matter

- 2. Claims 14, 15 and 17-19 are allowed.
- 3. The following is an examiner's statement of reasons for allowance: a method of diagnosing a processing apparatus including a vacuum process chamber wherein a semiconductor is treated by a plasma generated from a gas, the method comprising steps of:

imparting mechanical oscillation to the semiconductor processing apparatus; detecting the mechanical oscillation signals generated by imparting mechanical oscillation inside the apparatus; and analyzing detected signals to diagnose whether the vacuum process chamber is normally assembled and to specify a position inside the vacuum chamber which an abnormality has occurred. In another embodiment, the method determines a resonant frequency of a component by changing the frequency of the imparted mechanical oscillation to diagnose a condition of the component. In yet another embodiment, the oscillation imparting device and the reception device are juxtaposed with each other on a sidewall of the chamber, and the method includes analyzing the

detected signals to evaluate the thickness of a film formed on an inner wall of the chamber.

The closest prior art by Sakamoto et al teach an apparatus including an ultrasonic pulse generator and an oscillator measuring device for detecting the end point of a plasma etching process.

4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Maureen G. Arancibia whose telephone number is (571) 272-1219. The examiner can normally be reached on core hours of 10-5, Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on (571) 272-1435. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 1763

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Maureen G. Arancibia

Patent Examiner, Art Unit 1763

Parviz Hassanzadeh SPE, Art Unit 1763

P. Hanen Jedl